



Docket No.: 060188-0596

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

KIRIO MISAKA

Application No.: 10/688,960

Filed: October 21, 2003

For: A PATTERNING METHOD USING A PHOTOMASK

: Customer Number: 20277

: Confirmation Number: 3327

: Group Art Unit: 1756

: Examiner: SAGAR, KRIPA

RESPONSE UNDER 37 C.F.R. §1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to Office Action dated December 14, 2004, having a three-month shortened statutory period for response set to expire March 14, 2005, a petition for a one-month extension of time up to and including April 14, 2005, being filed concurrently herewith, reconsideration of the above-identified application is respectfully requested in view of the following comments and remarks.